

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PATENT

In re Application of MAJIMA et al.

Application No. 09/890,550

Examiner: VO, Hai

RECEIVED
CENTRAL FAX CENTER

APR 28 2005

Filed: January 14, 2002

Group Art Unit: 1771

For: POROUS SILICON CARBIDE SINTER AND SILICON CARBIDE-METAL
COMPOSITE THAT ARE OPTIMAL FOR A WAFER GRINDER TABLE

AMENDMENT

CERTIFICATE OF TRANSMISSION/MAILING

I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, Alexandria, VA 22313-1450 on 4-28-05.

 Reg. No. 40,764
Mark D. Passler

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

INTRODUCTORY COMMENTS

This is in response to the Office Action dated October 28, 2004. Please amend the above-identified application as follows:

Amendments to the claims begin on page 2 of this paper.

Remarks/arguments begin on page 5 of this paper.

{WP231692;1}